

Refine Search

Search Results -

Terms	Documents
(silicon adj nitride) same ((C4F6 or C5F8 or CF4 or C4F8 or C2F6 or C3F8 or chlorofluorocarbons) same ammonia same etch\$)	0

Database:

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Search:

L6

Refine Search

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 DATE: Tuesday, January 18, 2005 [Printable Copy](#) [Create Case](#)

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Name Query
 side by
 side

Hit
Count Set
 Name
 result set

DB=JPAB; PLUR=YES; OP=ADJ

L6 (silicon adj nitride) same ((C4F6 or C5F8 or CF4 or C4F8 or C2F6 or C3F8
 or chlorofluorocarbons) same ammonia same etch\$)

0 L6

DB=EPAB; PLUR=YES; OP=ADJ

L5 (silicon adj nitride) same ((C4F6 or C5F8 or CF4 or C4F8 or C2F6 or C3F8
 or chlorofluorocarbons) same ammonia same etch\$)

0 L5

DB=USPT; PLUR=YES; OP=ADJ

L4 (silicon adj nitride) same ((C4F6 or C5F8 or CF4 or C4F8 or C2F6 or C3F8
 or chlorofluorocarbons) same ammonia same etch\$)

1 L4

DB=PGPB; PLUR=YES; OP=ADJ

L3 (silicon adj nitride) same ((C4F6 or C5F8 or CF4 or C4F8 or C2F6 or C3F8
 or chlorofluorocarbons) same ammonia same etch\$)

2 L3

DB=TDBD; PLUR=YES; OP=ADJ

L2 (silicon adj nitride) same ((C4F6 or C5F8 or CF4 or C4F8 or C2F6 or C3F8
or chlorofluorocarbons) same ammonia same etch\$)

1 L2

DB=DWPI; PLUR=YES; OP=ADJ

L1 (silicon adj nitride) same ((C4F6 or C5F8 or CF4 or C4F8 or C2F6 or C3F8
or chlorofluorocarbons) same ammonia same etch\$)

2 L1

END OF SEARCH HISTORY